

Publikationen

(2020): Influencing factors for a continuous wave UV-laser component. In: Proceedings of SPIE 11478 (Seventh European Seminar on Precision Optics Manufacturing [8 July 2020; Teisnach]), Bellingham, WA, USA. DOI: 10.1117/12.2564916.

(2019): Processing of a new nonlinear optical crystal for continuous wave UV-laser applications. In: Proceedings of SPIE 11171 (Sixth European Seminar on Precision Optics Manufacturing, 1117101 [9-10 April 2019, Teisnach]), Bellingham, WA, USA. DOI: 10.1117/12.2528140.